# X-ray imaging telescopes: prediction of the expected image of the expected image quality from surface roughness metrology data



WHAT X-RAY ASTRONOMERS WANT: HIGH ANGULAR RESOLUTION ...



Chandra image, res. = 0.5 arcsec HEW

Swift XRT image, res. = 15 arcsec HEW

The angular resolution of X-ray telescopes is a fundamental requirement to resolve the details of celestial sources

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#### ... AND LARGE EFFECTIVE AREAS



• Most X-ray sources are faint, large collecting areas (~ 1000 cm<sup>2</sup>) are needed to increase the sensitivity.

• A limited mass (~ 300 kg) for the telescope to fly...!

 High stability in orbital environment (variations of temperature, cosmic rays, micrometeoroids, ...)

X-ray telescopes must have the capability to detect *extremely weak fluxes* (down to 10<sup>-8</sup> ph/s/cm<sup>2</sup>/keV).

To date, the energy range 10 - 100 keV has still to be explored with *direct imaging* telescopes.

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-0.2

ASTRONOMERS LIKE USING THE HEW (= Half Energy Width)

Other parameters (like FWHM) would be, in general, nonrepresentative of the optical performances (exception: nearby sources)

Credits: MPE/PANTER

3100

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### A NEW HARD X-RAY MISSION

SIMBOL-X (CNES-ASI joint venture)



SIMBOL-X will allow the extension of imaging capabilities to the hard X-ray band by adopting:

| Focal length           | 20 m                   |
|------------------------|------------------------|
| Min diameter           | 300 mm                 |
| Max diameter           | 700 mm                 |
| Min incidence angle    | 0.11 deg               |
| Max incidence angle    | 0.25 deg               |
| Energy band            | 0.5 – 80 keV           |
| Number of shells       | 100                    |
| Effective area (1 keV) | ~ 1400 cm <sup>2</sup> |
| Effect. area (30 keV)  | ~ 450 cm <sup>2</sup>  |
| Field of View          | 12 arcmin              |
| Required HEW           | 15 arcsec (1 keV)      |
|                        | 20 arcsec (40 keV)     |

• Very shallow incidence angles (0.1-0.25 deg), made possible by a 20 m focal length, managed with the formation flight configuration.

• Graded multilayer coatings to enhance mirrors' reflectivity up to 80 keV

G. Pareschi, P. Ferrando, "*The SIMBOL-X hard X-ray mission*", Exp. Astron. 20, 139-149 (2006) ACTOP 08, D. Spiga (INAF/Osservatorio Astronomico di Brera, Italy)



#### METROLOGICAL INSTRUMENTATION FOR MIRROR DIAGNOSTIC AT INAF-OAB



Long-Trace profilometer – suitable for stress-induced deformations



Nomarski Phase Contrast microscope

5x - 100 x



WYKO profilometer 1D surface profiles 2.5, 0.6 mm wide scans





2 Atomic Force Microscopes 2D surface maps (plane and curved substrates): 100, 10 1 µm wide scans

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# X-RAY MIRROR SURFACE ROUGHNESS MEASUREMENTS

• Each instrument is sensitive only to a particular window of spatial frequencies.



#### REPRESENTATION IN TERMS OF POWER-SPECTRAL DENSITY

Representing the roughness in terms of PSD (Power-Spectral-Density) has several advantages (and at least a disadvantage):

$$P(f) = \frac{1}{L} \left| \int_{0}^{L} z(x) e^{-2\pi i f x} dx \right|^{2}$$

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# DIRECT DERIVATION OF THE $H(\lambda)$ FROM A SURFACE PSD

PSD  $\mapsto$  H( $\lambda$ )

Spiga D., 2007, "Analytical evaluation of the X-ray scattering contribution to imaging degradation ingrazing-incidence X-ray telescopes". Astronomy and Astrophysics, vol. 468, 775-784

$$\int_{f_0}^{2/\lambda} P(f) df = \frac{\lambda^2}{16\pi^2 \sin^2 \vartheta_i} \ln\left(\frac{2N}{2N-1}\right)$$

$$\rightarrow$$
 derive  $f_0 \rightarrow H(\lambda) = \frac{2\lambda f_0}{\sin \vartheta_i}$ 

N: number of identical reflections  $\theta_i$ : grazing incidence angle



- $\lambda$  : photon wavelength
- f: surface spatial frequency



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 $2\lambda f_0$ 

# DIRECT DERIVATION OF THE $H(\lambda)$ FROM A SURFACE PSD

#### For a fractal surface

Spiga D., 2007, "Analytical evaluation of the X-ray scattering contribution to imaging degradation ingrazing-incidence X-ray telescopes". Astronomy and Astrophysics, vol. 468, 775–784



## DIRECT DERIVATION OF THE PSD FROM A $H(\lambda)$ FUNCTION

PSD  $H(\lambda)$ 

Spiga D., 2007, "Analytical evaluation of the X-ray scattering contribution to imaging degradation ingrazing-incidence X-ray telescopes". Astronomy and Astrophysics, vol. 468, 775-784

$$\frac{P(f_0)}{\lambda} \frac{d}{d\lambda} \left(\frac{H(\lambda)}{\lambda}\right) + \frac{1}{4\pi^2 \sin^3 \vartheta_i} \ln\left(\frac{2N}{2N-1}\right) \approx 0$$

At the frequency

$$f_0 = \frac{H(\lambda)}{2\lambda} \sin \vartheta_i$$

- N: number of identical reflections
- λ : photon wavelength
- $\theta_i$  : grazing incidence angle
- f: surface spatial frequency

These formulae can be useful to translate HEW requirements into PSD tolerances !!!!





# FINAL REMARKS

• Active optics for X-rays can correct the mirror profiles, but what if X-ray scattering due to roughness degrades the image?

• X-ray scattering seems to pose the main threat to the telescope angular resolution. Clear roughness tolerances should be established from scientific requirements of the telescope.

• Treatment of roughness in terms of PSD allows to relate it PSD to the expected HEW trend, as a function of  $\lambda$  (and vice versa).

• Application of simple formulae allows determining the surface finishing tolerances for focusing mirrors in soft and hard X-rays.

# FUTURE WORK

• Extending the formalism to any multilayer coating.

• Apply the method to explain the angular resolution of existing X-ray telescopes like Swift/Jet-X.

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